

METHOD AND APPARATUS FOR PRODUCING DATA STORAGE MEDIA

Abstract of Disclosure

In one embodiment, the method for producing a stamper, comprises: forming a nickel plated substrate having desired surface features on one side; disposing a managed heat transfer layer on a second side of said substrate; forming a thickness of said managed heat transfer layer having a variation of less than about 5%; and altering said exposed surface of said managed heat transfer layer. Also disclosed are a method and apparatus for producing data storage media.

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